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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

H. Jim Fulford et al.

Serial No.: 09/818,666

Filed: March 27, 2001

Group Art Unit: 1765

Examiner: Tran, Binh X.

Atty. Dkt. No.: 2000.045900

For: Method and Apparatus for Providing Etch  
Uniformity Using Zoned Temperature  
Control

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I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on the date below:	
<u>02/03/03</u> Date	<u>Kathryn Maras</u> Signature

**RESPONSE TO FIRST OFFICE ACTION DATED NOVEMBER 21, 2002**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

This paper is submitted in response to the Office Action dated November 21, 2002 for which the shortened-statutory period for response is set to expire on February 21, 2003. Because this response is filed within the shortened-statutory period for response, it is believed that no fees are due in connection with the filing of this paper. Should, however, the Office require any extensions of time or other fees deemed necessary for entry of this paper, please consider this paragraph such a request and authorization for the Assistant Commissioner to withdraw the